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APPLICANTS

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** CONTINUING DATA *Qd*** FOREIGN APPLICATIONS *Qd*

REPUBLIC OF KOREA 2002-84281 12/26/2002

REPUBLIC OF KOREA 2002-65754 10/28/2002 *OK*

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>Qd</i>		DRAWING 8	18	3
Verified and Acknowledged	Examiner's Signature <i>Qd</i> Initials				

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TITLE

Method of forming isolation films in semiconductor devices

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
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